

Search Notes

Application No.

09/894,334

Examiner

W. David Coleman

Applicant(s)

MA ET AL.

Art Unit

2823

SEARCHED

| Class | Subclass | Date | Examiner |
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| 438 | 52 | 2/6/2004 | WDC |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
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| EAST 1.4, Applicant claims a process of fabricating a MEMS device which incorporates a sacrificial layer. | 2/9/2004 | WDC |
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